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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Ilya Perlov et al.
Serial No. : 09/507,172
Filed : February 18, 2000
Title : CHEMICAL MECHANICAL POLISHING SYSTEM HAVING MULTIPLE
POLISHING STATIONS AND PROVIDING RELATIVE LINEAR MOTION

Art Unit : 3723
Examiner : Timothy V. Eley

Commissioner for Patents
Washington, D.C. 20231

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JAN 28 2002

OFFICE OF PETITIONS

PETITION TO REVIVE APPLICATION UNDER 37 CFR §1.137(b)

Applicant hereby petitions under 37 CFR §1.137(b) to revive the above application, which was abandoned on November 22, 2001 for failure to respond to an Election/Restriction mailed May 22, 2001.

Enclosed is 1) a proposed response to the Election/Requirement to continue prosecution of the application and 2) a check for \$1280 in payment of the petition fee by a large entity as set forth in 37 CFR §1.17(m).

Applicant submits that the entire period of delay was unintentional.

Please apply any other charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: 12/11/01

David J. Goren
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CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, Washington, D.C. 20231.

December 11, 2001.
Date of Deposit

Matilde C. Sanchez
Signature

Matilde C. Sanchez
Typed or Printed Name of Person Signing Certificate

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